

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 6, 2009

In re the Application of

Takaaki NODA et al.

Group Art Unit: 1792

Application No.: 10/587,500

Examiner: K. STOUFFER

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND APPARATUS FOR
PROCESSING SUBSTRATE

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

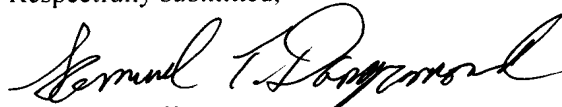
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 8, 2009, an extension of time for a period of one month is hereby requested.

The fees associated with this filing under 37 C.F.R. §1.136(a) are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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